

PLEASE ST/AMP TO ACKNOWLEDGE RECEIPT OF THE FOLLOWING:  
In Re Application of:

Serial No.: 09/784,200

Filed: February 26, 2001

For: CHEMICAL LIQUID PROCESSING APPARATUS FOR PROCESSING A  
SUBSTRATE AND THE METHOD THEREOF

**BOX MISSING PART**

1. Check for \$ 130.00
2. Response To Notice To File Missing Parts
3. Copy of Notice To File Missing Parts
4. Declaration and Power of Attorney
5. Claim For Priority
6. Certified copies of Japanese Application Nos. 2000-039683 and 2000-297441, filed February 17, 2000 and September 28, 2000, respectively.

Dated: May 22, 2001

CASE REF: 03180.0273

RVB/FPD/bl

(Due Date: May 22, 2001)



MAY 22 2001

*Handwritten signature/initials*

Attorney Docket No.:03180.0273

Customer Number: 22,852

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Shinichi ITO et al.

Serial No.: 09/784,200

Group Art Unit: 1762

Filed: February 16, 2001

Examiner:

For: CHEMICAL LIQUID PROCESSING APPARATUS FOR PROCESSING A  
SUBSTRATE AND THE METHOD THEREOF**CLAIM FOR PRIORITY**Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

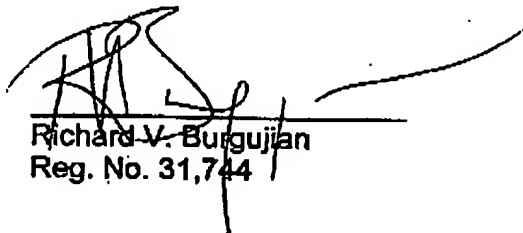
Under the provisions of 35 U.S.C. § 119, Applicants hereby claim the benefit of the filing date of Japanese Patent Application Nos. 2000-039683 and 2000-297441, filed February 17, 2000 and September 28, 2000, respectively, for the above-identified U.S. patent application.

In support of this claim for priority, enclosed are two certified copies of the priority applications.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

By:

  
Richard V. Burgujian  
Reg. No. 31,744Date: May 22, 2001  
RVB/FPD/bl  
Enclosures

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202-408-4000

日 本 国 特 許 庁  
PATENT OFFICE  
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されて  
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed  
with this Office.

出 願 年 月 日

Date of Application:

2000年 2月17日

出 願 番 号

Application Number:

特願2000-039683

出 願 人

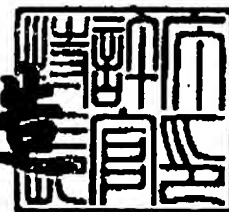
Applicant (s):

株式会社東芝

2000年11月10日

特 許 庁 長 官  
Commissioner,  
Patent Office

及 川 耕 造



出証番号 出証特2000-3094618

日 本 国 特 許 庁  
PATENT OFFICE  
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されて  
る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed  
with this Office.

出 願 年 月 日  
Date of Application:

2000年 9月28日

出 願 番 号  
Application Number:

特願2000-297441

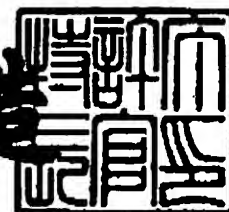
出 願 人  
Applicant(s):

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2001年 3月 2日

特許庁長官  
Commissioner,  
Patent Office

及 川 耕 造



出証番号 出証特2001-3012425